Attorney Docket No. 13DV-14080 (07783-0096)

## AMENDMENTS TO THE SPECIFICATION B

Please amend the abstract as follows:

## **ABSTRACT**

The present invention is A process for forming diffusion aluminide coatings on an uncoated surface of a substrate, without interdiffusing a sufficient amount of aluminum into a coating layer to adversely affect the coating growth potential and mechanical properties of said coating layer. A metal substrate is provided comprising an external surface and an internal passage therein defined by an internal surface, at least a portion of the external surface of the substrate being coated with a coating layer selected from the group consisting of β-NiAl-base, MCrAlX, a line-of-sight diffusion aluminide, a nonline-of-sight diffusion aluminide, a pack diffusion aluminide, and a slurry diffusion aluminide on said substrate. The external surface of the substrate is cleaned. The metal substrate is subjected to an [[a]] aluminum vapor phase deposition process performed-using-a-fluorine-containing-activator-solocted-from the group consisting of AIF., CrE3. NH<sub>4</sub>F, and combinations thereof, at a rate in the range of about 0.036 mole of-fluorine-per-ft<sup>3</sup>/hr-of-transport-gas to about 0.18 mols of fluorine-per-ft<sup>3</sup>/hr-of-transport gas, at a temperature in the range of about 1350°F (730°C) to about 1925°F (1050°C), using a transport gas selected from the group consisting of argon, nitrogen, hydrogen, and combinations thereof, the transport gas being provided at a flow rate in the range of about 20 ft<sup>3</sup>/hr to about 120 ft<sup>3</sup>/hr for a period of time in the range of about 2 hours to about 10 hours. The substrate is then cooled.